

Notice of References Cited	Application/Control No. 10/624,203	Applicant(s)/Patent Under Reexamination GRUDOWSKI, PAUL A.	
	Examiner Fernando L. Toledo	Art Unit 2823	Page 1 of 1

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NON-PATENT DOCUMENTS

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	U	Wolf and Tauber; Silicon Processing for the VLSI Era Volume 1: Process Technology; Lattice Press, 1986, page 192
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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